

YOUR SIDEKICK FOR LASER OPTICS DEVELOPMENT

S1: (CX, arrow marks) AR<0.1% @ 950-1050 nm, AOI 0 deg. S2: (PL) AR<0.1% @ 950-1050 nm, AOI 0 deg.

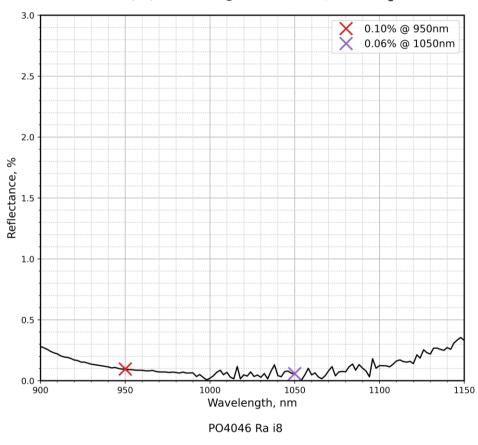


Fig. 1.

SIDE MEASURED: S1 only (grinded witness sample)

COMMENTS: Margin of measurement error: +/-0.25%

S1: (CX, arrow marks) AR<0.1% @ 950-1050 nm, AOI 0 deg. S2: (PL) AR<0.1% @ 950-1050 nm, AOI 0 deg.

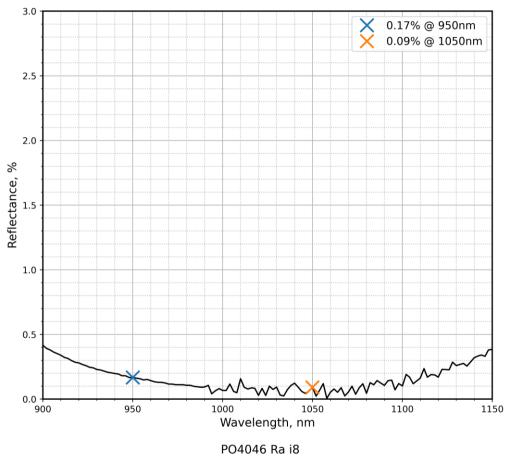


Fig. 2.

SIDE MEASURED: S2 only (grinded witness sample)

COMMENTS: Margin of measurement error: +/-0.25%